

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

	Pan et al.	Docket No.:	TI-31192
Serial No.:	09/998,606	Examiner:	Nguyen, C.
Filed:	11/30/01	Art Unit:	2811
Customer No.:	23494	Conf. No.:	4902
For:	HIGH DENSITY CAPACITOR USING TOPOGRAPHIC SURFACE		

REPLY UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The following remarks are offered in response to the Examiner's Office Action dated November 3, 2008. They are respectfully submitted as a full and complete response to that Action.

REMARKS

Reconsideration of the above-referenced application in view of the following remarks is respectfully requested.

Claims 18-22 are pending in this case.

The Examiner rejected claims 18-20 under 35 U.S.C. § 103(a) as being unpatentable over Vaartstra (U.S. Patent 6,010,969) in view of Ouellet et al. (U.S. Patent 6,268,620) and further in view of Yu et al. (U.S. Patent 6,211,008).